Docket No.: 21058/1206448-US1

Examiner: F. W. Lu

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Selena Chan et al.

Application No.: 10/667,004 Confirmation No.: 6646

Filed: September 19, 2003 Art Unit: 1634

For: CONTROLLED ALIGNMENT OF

NANOBARCODES ENCODING SPECIFIC INFORMATION FOR SCANNING PROBE MICROSCOPY (SPM) READING

REQUEST FOR ACKNOWLEDGMENT OF IDS

MS Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the Notice of Allowance, dated September 8, 2008, Applicants respectfully request the Examiner's acknowledgment of the Information Disclosure Statement electronically filed on February 8, 2008. For the Examiner's convenience, we attach a copy of the as-filed Information Disclosure Statement hereto.

As the Issue Fee is due to be paid in this application by December 8, 2008, Applicants would appreciate receiving the Examiner's acknowledgement that the cited reference has been considered and made of record.

It is respectfully submitted that no fees are required for this filing, however, the Director is authorized is authorized to charge any applicable fees and/or credit any overpayments to Deposit Application No. 10/667,004 Docket No.: 21058/1206448-US1

Communication dated November 20, 2008 Request for Acknowledgment of IDS

Account No. 04-0100 referencing docket no. 21058/1206448-US1.

Dated: November 20, 2008 Respectfully submitted,

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